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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (Use as many sheets as necessary)				<b>Complete if Known</b>	
				Application Number	10/769,821
				Filing Date	February 3, 2004
				First Named Inventor	Shunpei YAMAZAKI
				Art Unit	1715
				Examiner Name	J. LIN
Sheet	1	of	2	Attorney Docket Number	740756-2705

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US-6,319,321 B1	11-20-2001	HIRAGA et al.	
		US-2004/0253896 A1	12-16-2004	YAMAZAKI	
		US-6,784,118 B2	08-31-2004	HAYASHI et al.	
		US-2002/0191122 A1	12-19-2002	TANAKA et al.	
		US-5,885,661	03-23-1999	BATCHELDER	
		US-2004/0209190 A1	10-21-2004	MORI et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
		JP-06-182980	07-05-1994			Full
		JP-2000-258921	09-22-2000			Abst.
		WO-2002/027390 A2	04-04-2002			Eng.

Examiner Signature	Date Considered
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				Sheet	2

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
		GABRIEL.C et al., "Integration of metal masking and etching for deep submicron patterning," J. VAC. SCI. TECHNOL. A (JOURNAL OF VACUUM SCIENCE & TECHNOLOGY A), July 1, 2000, Vol. 18, No. 4, pp. 1420-1424.	Eng.
		WOLF.S et al., SILICON PROCESSING FOR THE VLSI ERA, 1986, Vol. 1, pp. 407-409, 427-429, 434-437, LATTICE PRESS.	Eng.

Examiner Signature	/James Lin/	Date Considered	07/06/2011
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